



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 24, 2025	
IGI Report Number	LG723511724
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	5.83 X 5.69 X 3.81 MM

GRADING RESULTS

Carat Weight	1.09 CARAT
Color Grade	FANCY INTENSE YELLOW
Clarity Grade	VS 1

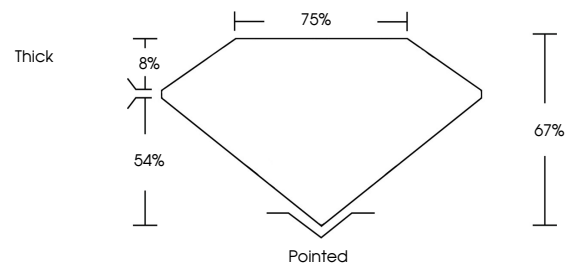
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG723511724

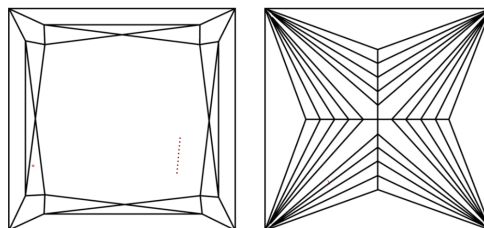
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

LG723511724
Report verification at igi.org

PROPORTIONS

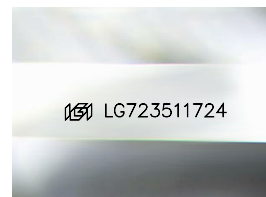


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

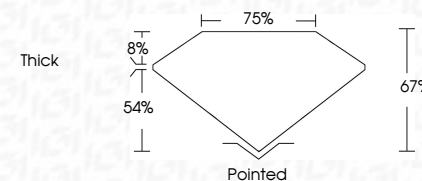
IF VS¹⁻² VS¹⁻² S¹⁻² |¹⁻³

Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG72351172A
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.	



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www.igi.org

July 24, 2025
 CGI Report No LG723511724
 PRINCESS CLIT

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